



501.39082X00

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: S. UNO, et al.
Application No.: 09/646,671
Filed: September 20, 2000
For: METHOD OF MANUFACTURE OF SEMICONDUCTOR
INTEGRATED CIRCUIT DEVICE AND
SEMICONDUCTOR INTEGRATED CIRCUIT DEVICE
(As Amended)
Group: 2812
Examiner: L. Gurley

AMENDMENT

Mail Stop Amendment
Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 21, 2004

Sir:

In response to the Office Action mailed May 21, 2004, please amend the
above-identified application as listed in the following, and as set forth on the
following pages:

Amendments to the Claims; and

Remarks are included following the amendments.